



Attorney's Docket No.: 042390.P4222D2

RECEIVED  
OCT 15 2002  
Patent  
TECHNOLOGY CENTER 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: )  
 )  
Robert S. Chau, et al. )  
 )  
Application No:09/654,315 )  
 )  
Filed: September 1, 2000 )  
 )  
For: DEVICE STRUCTURE AND METHOD )  
FOR REDUCING SILICIDE )  
ENCROACHMENT )

Examiner: Tran, T.F.  
Art Unit: 2811

#8/Ext of time  
2 times  
Amult B  
10/28/02  
Amund

Commissioner for Patents  
Washington, D.C. 20231

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed April 1, 2002, Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner of Patents, Washington, D.C. 20231

on October 1, 2002  
Date of Deposit

Teresa Edwards  
Name of Person Mailing Correspondence  
Teresa Edwards October 1, 2002  
Signature Date

10/11/2002 EHAILE1 00000038 09654315  
01 FC:117 920.00 DP

B